



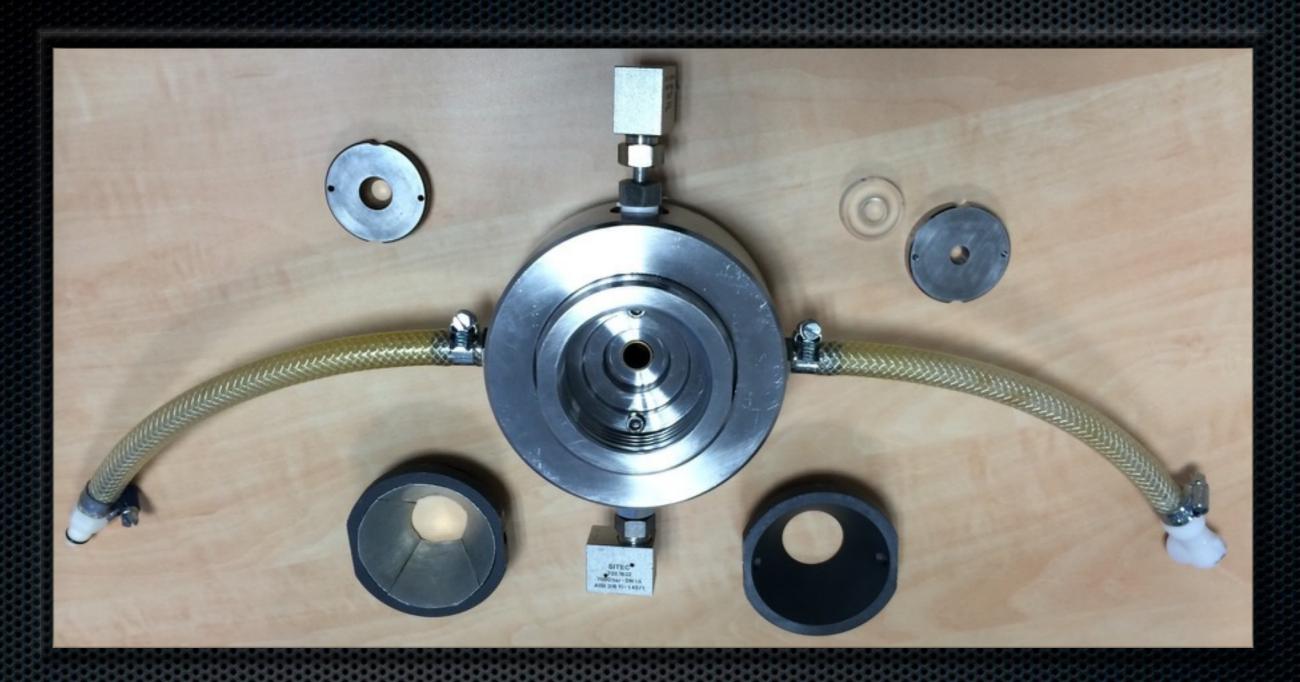
SBM-JRA Meeting High Pressure Cells for NSE/SANS

Julien Gonthier et al.

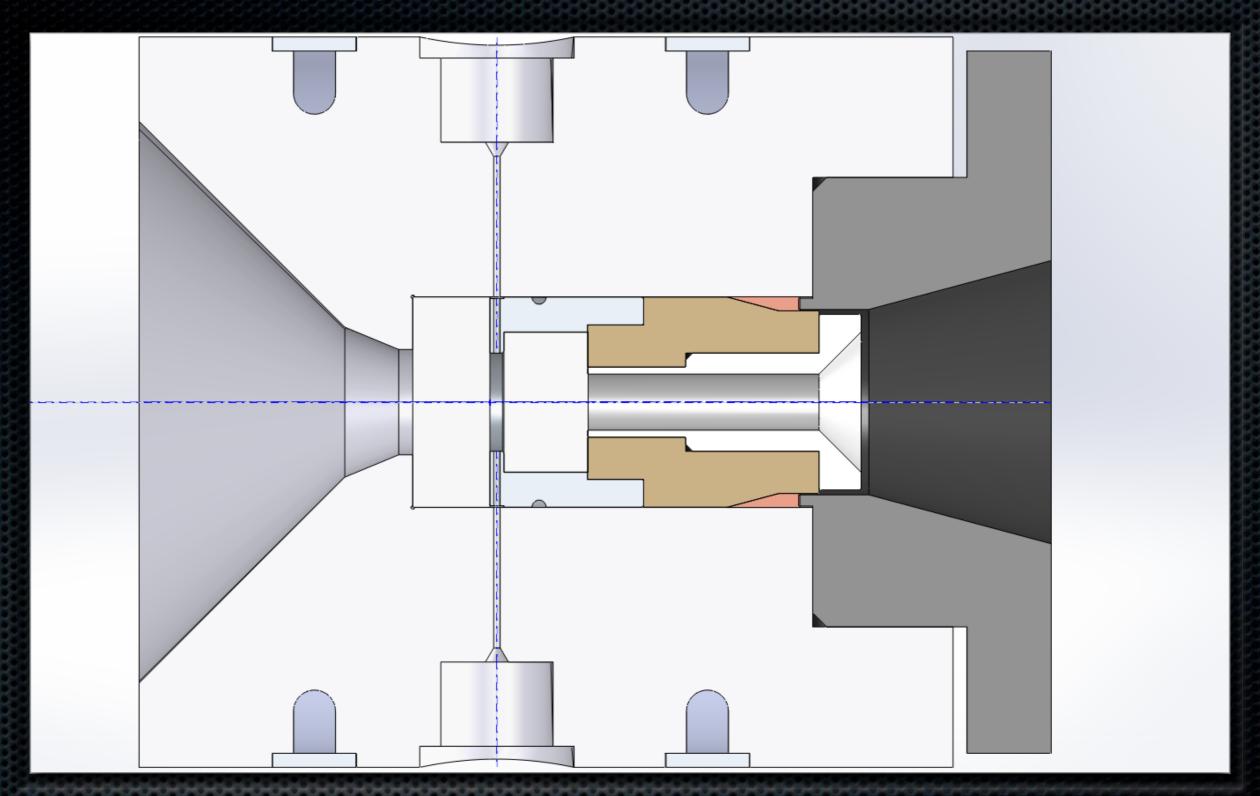
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HP Cells for NSE/SANS

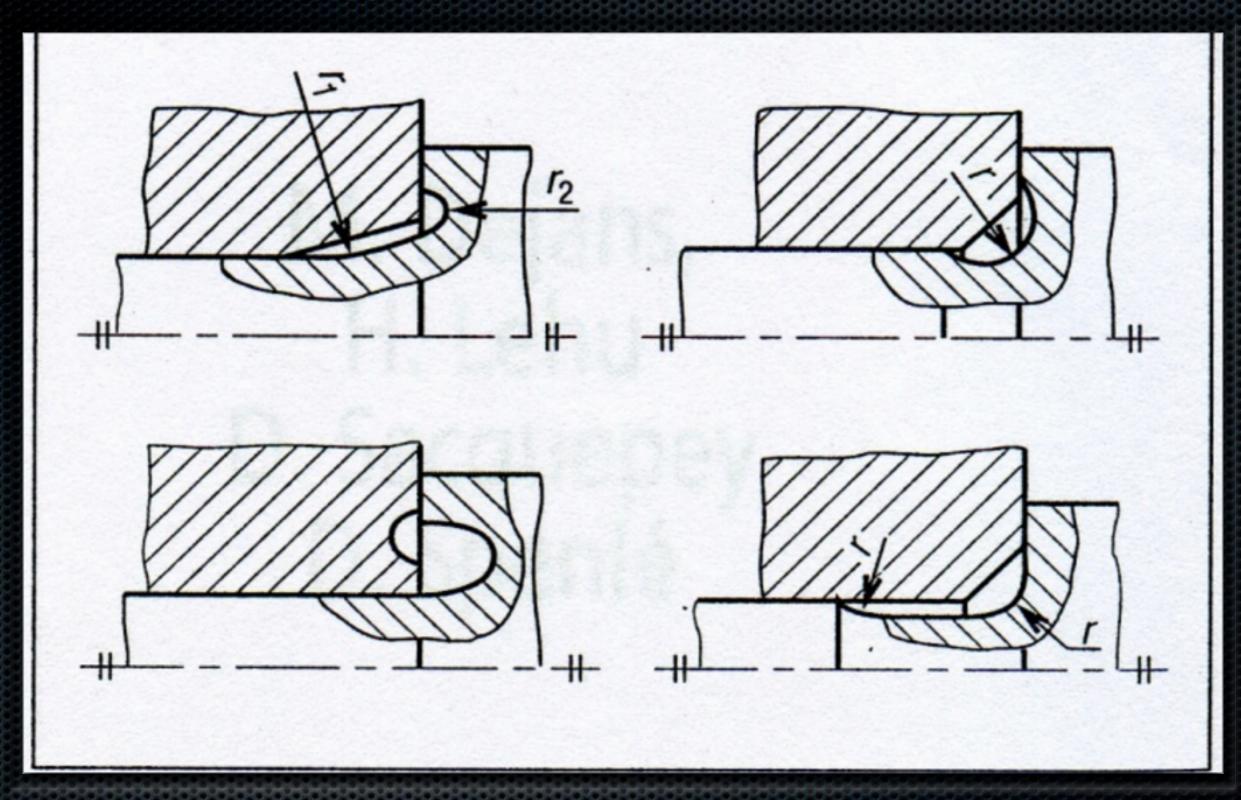
- Pressure range: 0 to 5 kbar
- Temperature range: 0 to 100 °C
- 35° 60° access to the scattered beam
- Bio-compatible
- Non-magnetic for NSE



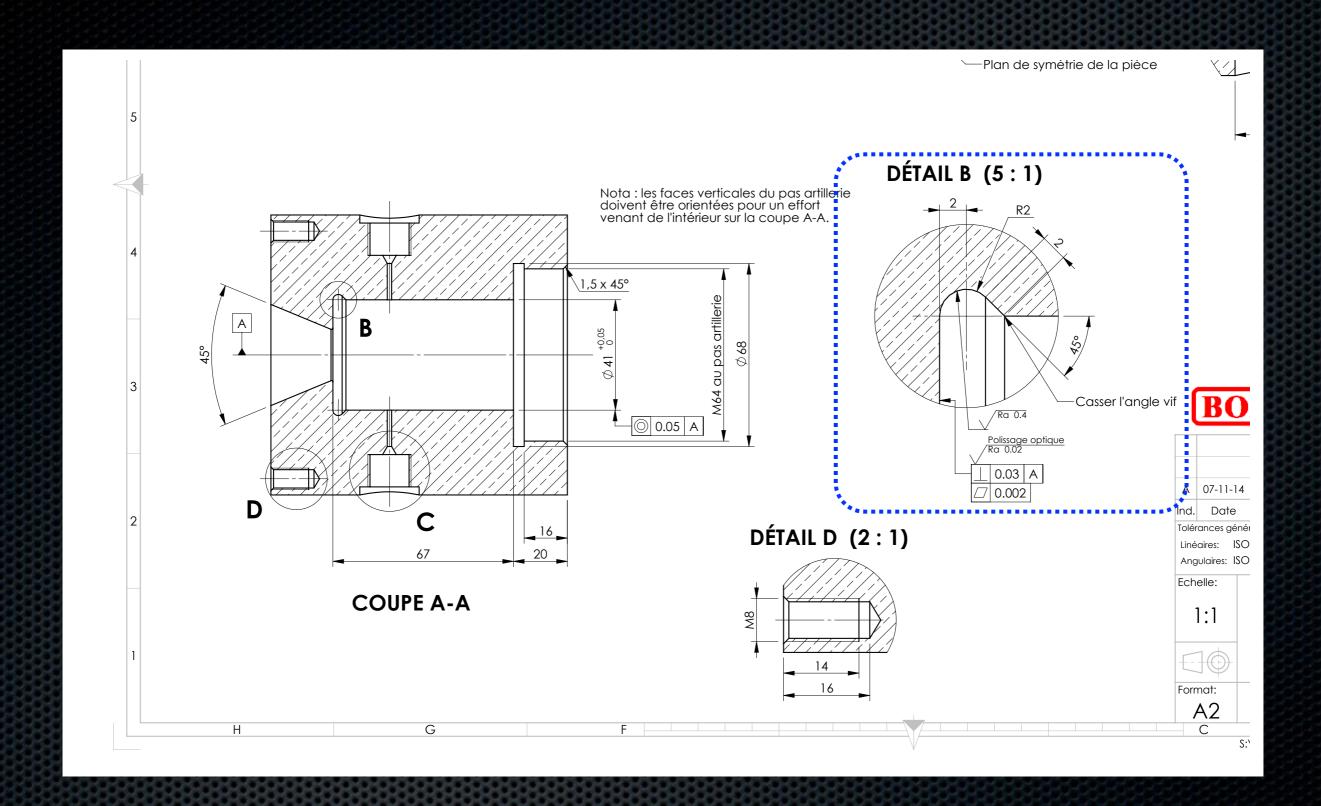
Nova Swiss French supplier



First draft (May 2014)



Reduce stress concentration



Reduce stress concentration

Sapphire windows

 $T/D = 1.06(p/F_a)^{0.5}$

Fro. 1. Cross section view of high pressure, high temperature spectrophotometer cell. A—Holes for heaters; B—hole for thermistor C—windows; D—spacer; E—0-ring; F—copper seat; G—screwing; H—sample cavity; I—cell entrance; I—cell exit.

APPARATUS

Design and Construction of the Cell Body

Thickness / mm

Maximated Fees Suffeess ster are con-

osive solutions. An assembled and exploded cross section new of the cell is reproduced in Fig. 1. The cell is relatively compact, measuring 9.50 cm (long—parallel to ight path) by 8.00 cm (high) by 6.35 cm (deep). It has seen used in a variety of commercially available in an abottometer. (i.e., Perkin Elman 221

photometers (i.e., Perkin-Elmer 221; , and 12; Cary 14; and Perkin-Elmer It the need for special instrument s been drilled at the four corners (A) ges and at (B) for a thermistor. Heat

applied by four $50 \,\mathrm{W}$ tubular heaters. Temperature anges are detected and the temperature of the cell is aintained at $\pm 5 \,^{\circ}\mathrm{C}$ of the set temperature using a sermistor temperature controller.

Unsupported findiameter / mm

(C) are field apart by a Hastelloy spacer (D) until pressure is applied. The p-rings (E) encompass the wilder by hid are compressed between the spacer (D) and the soft copper seats (F) by the screw plugs (G) to form the initial seal. The reaction solutions are introduced into the sample cavity (H) through a hole in the cell body (I) and removed through a similar hole at the top of the cell (J). The openings at (I) and (J) are tapped for 6.35 mm Aminco high-pressure fittings.

A variety of spacers have been designed to produce path lengths of from 2.0 cm down to 0.05 mm. When a spacer smaller than 2.0 cm is employed, washers of the appropriate thickness are inserted between the windows (C) and the screw plugs (G) to extend the depth of these back-up plugs (G).

Spacers less than 1 mm are of the different design shown in Fig. 2. The spacer plates (K) are sandwiched between two rings (L) to maintain the proper path length

and the entire assembly is held together with four pins (M) as shown in the right portion of Fig. 2. Two spacer plates (K) with an opening between them are used to allow solution to enter the sample compartment. The hole in the assembled system (N) is present for the same reason. The inside diameter of (L) is comparable to the diameter of the windows so that they may slip inside (L) and be held apart only by the spacers (K).

The Windows and Seals

The cell body and related metal components are able to withstand several thousand atmospheres at 250°C. However, the window material and the seals are the weak points in the equipment.

Most studies have been performed using CaF₂ windows 1.27 cm thick and 2.35 cm diam. The useful spectral range for CaF₂ (1.27 cm thick) is from the visible to about 1400 cm⁻¹ (7140 nm). Sapphire, which is much stronger than CaF₂ and less likely to break, is transparent from the uv only to about 2300 cm⁻¹ (4340 nm). Pressed MgF₂ has mechanical strength similar to CaF₂ but transmits only about one-half as much energy. KRS-5 (a TlBr-TlI mixture) has mechanical strength comparable to CaF₂ and is transparent to about 300 cm⁻¹ (33 300 nm).

The maximum pressure the windows will withstand is related to the thickness and unsupported diameter—the diameter of the opening in back-up plug (G)—of the window by Eq. (1)¹⁵:

$$T/D = 1.06(p/F_a)^{0.5},$$
 (1)

where T is the window thickness, 1.27 cm; D is the unsupported diameter, 1.27 cm; p is the maximum pressure the window will withstand; and F_a are the apparent elastic limits (atm). This equation is valid at 25°C and contains a safety factor of 4. The F_a for calcium fluoride is 360 atm, consequently at 25°C the cell as designed will withstand at least 340 atm. If the safety factor of 4 is not considered, the cell should withstand \sim 1360 atm.

The maximum pressure could be increased by decreasing the unsupported area of the windows. However, this would involve a simultaneous decrease in the quantity of transmitted radiation, and at some diameter as the cell opening decreases a beam condenser and optical bench would be required to insure that sufficient energy reaches the detector to produce satisfactory spectra.

No systematic study has been performed to determine the rupture point of the windows or seals.

Fig. 2. Spacer subassembly for path lengths of 1.0 mm or less. K—Spacer plates; L—ring to support spacer plates; M—assembly pins; N—hole to introduce sample.







Sapphire windows

Sapphires for SANS/NSE HP cell up to 200 MPa.nb | 1 Sapphires for SANS/NSE HP cell up to 200 MPa

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Inlet sapphire window
Unsupported diameter: Øu (mm)
Øu = 12.4
Maximal working pressure: MaxPressure (MPa)
MaxPressure = 200
200
Yield strength of Sapphire (MPa)
190
The ratio of thickness to unsupported diameter is given by (without safety factor):
ratio = 1.06 * Sqrt[MaxPressure / (4 * YS)]
The minimal thickness (in mm) of the sapphire window is given by:
MinThickness = Øu * ratio
Outlet sapphire window
Unsupported diameter: Øu (mm)
Maximal working pressure: MaxPressure (MPa)
MaxPressure = 200
200
Yield strength of Sapphire (MPa)
YS = 190
190
The ratio of thickness to unsupported diameter is given by (without safety factor):
ratio = 1.06 * Sqrt[MaxPressure / (4 * YS)]
0.543769
The minimal thickness (in mm) of the sapphire window is given by:
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Sapphires for SANS/NSE HP cell up to 600 MPa
     Inlet sapphire window
     Unsupported diameter: Øu (mm)
     \emptyset u = 12.4
     12.4
     Maximal working pressure: MaxPressure (MPa)
     MaxPressure = 600
     Yield strength of Sapphire (MPa)
     YS = 190
     The ratio of thickness to unsupported diameter is given by (without safety factor):
     ratio = 1.06 * Sqrt[MaxPressure / (4 * YS)]
     The minimal thickness (in mm) of the sapphire window is given by:
     MinThickness = Øu * ratio
     Outlet sapphire window
     Unsupported diameter: Øu (mm)
     Maximal working pressure: MaxPressure (MPa)
     MaxPressure = 600
     Yield strength of Sapphire (MPa)
     YS = 190
     190
     The ratio of thickness to unsupported diameter is given by (without safety factor):
     ratio = 1.06 * Sqrt[MaxPressure / (4 * YS)]
    0.941835
     The minimal thickness (in mm) of the sapphire window is given by:
```